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EXPEDITED PROCEDURE

RESPONSE UNDER 37 CFR 1.116 – EXAMINING GROUP 1765

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
PATENT APPLICATION

Application No.:	09/683,088	Atty. Docket: BUR9-2000-0077-US1
Applicant:	Chu et al.	Today's Date: February 3, 2004
Filing Date:	November 16, 2001	Examiner: Matthew J. Song
Title: SINGLE REACTOR, MULTI-PRESSURE CHEMICAL VAPOR DEPOSITION FOR SEMICONDUCTOR DEVICES		Group Art Unit: 1765
		Fax: 703-872-9306

Amendments After Final Under 37 CFR 1.116

Amendment B

Honorable Commissioner of Patents and Trademarks
Washington, D.C. 20231

Sir:

In response to the Final Office Action dated December 3, 2003, Applicants respectfully request reconsideration of the outstanding rejections and reexamination of the present application in light of the following amendments and remarks.

CERTIFICATE OF MAILING	
I hereby certify that, on the date shown below, this correspondence is being:	
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<input type="checkbox"/> deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, Alexandria, VA 22313-1450.	<input checked="" type="checkbox"/> transmitted by facsimile to the Patent and Trademark Office.
Date: <u>02/03/2004</u>	<u>ANTHONY J. CANALE</u> Name
	<u>Anthony J. Canale</u> Signature

BUR9-2000-0077-US1
09/683,088